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McMaster Engineering Physics Journal
1280 Main St. W,
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Dear Dr. A. Turak,

Please consider the attached manuscript "**Assembly of a Four Point Probe that Operates under the Van der Pauw Method**" for publication in the McMaster Journal of Engineering Physics.

This research provides information on the importance of four point probes in the semiconductor industry and the components necessary to build your very own in lab four point probe. The research outlines two different methods of taking four point probe measurements, inline and Van der Pauw, and compares them. The four point probe is assembled with the consideration of keeping costs as minimal as possible, while maintaining an acceptable efficiency in the measurements. The research also outlines improvements that can be made to the four point probe assembly, but were not, due to time constraints.

I believe that this research will not only give the readers an in depth look into the blueprint of a four point probe, but will also be simple enough for newcomers to the journal to understand the importance of the four point probe in the semiconductor industry.

Thank you for taking the time to consider this submission, and please contact me if you have any questions or need any further information.

Sincerely,

Lazar Kojovic
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Undergraduate Researcher
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